

Docket: 8836-221 (IE13077-US)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Myoung-Ho Jung

Examiner: Gregory E. Webb

Serial No.: 10/748,903

Group Art Unit: 1751

Filed: December 30, 2003

*Do Not Allow  
enter.*

For: **CLEANING SOLUTION USED IN PROCESS OF FABRICATING  
SEMICONDUCTOR DEVICE**

*No RCE  
included*

Mail Stop: RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated December 12, 2006, please amend the above-referenced patent application as set forth herein. Also, accompanying this amendment is a Request for Continued Examination (RCE). ?

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